

# WEST

## Searches for User *jhollington* (Count = 10004)

Queries 9955 through 10004.

S #	Updt	Database	Query	Time	Comment
<u>S10004</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD	5532613.pn. and 53	2003-08-13 08:39:40	
<u>S10003</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD	(guide plate same glass ) and probe	2003-08-12 15:15:20	
<u>S10002</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD	(guide plate same glass ) and probe needle	2003-08-12 15:14:06	
<u>S10001</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD	guide plate same glass	2003-08-12 15:13:45	
<u>S10000</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD	(probe and guide plate ) and glass	2003-08-12 15:08:20	
<u>S9999</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD	probe and guide plate	2003-08-12 15:06:46	
<u>S9998</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD	(probe and glass wafer ) and (aperture or hole)	2003-08-12 10:57:30	
<u>S9997</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD	(probe and glass wafer ) and ((324/\$)!.CCLS.)	2003-08-12 10:41:42	
<u>S9996</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD	probe and glass wafer	2003-08-12 10:41:17	
<u>S9995</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD	((glass wafer )and probe ) and aperture	2003-08-11 14:12:28	
<u>S9994</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD	(glass wafer ) and probe	2003-08-11 14:10:36	
<u>S9993</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD	(glass wafer ) and ((324/\$)!.CCLS.)	2003-08-11 14:01:20	
<u>S9992</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD	glass wafer	2003-08-11 14:01:00	
<u>S9991</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD	((interface device	2003-08-11	

		and probe )and glass ) and ((324/\$)!.CCLS.)	12:34:04
<u>S9990</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD ((interface device and probe )and glass ) and ((3224/\$)!.CCLS.)	2003-08-11 12:33:54
<u>S9989</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD (interface device and probe ) and glass material	2003-08-11 12:28:29
<u>S9988</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD ((interface device and probe )and glass ) and borosilicate	2003-08-11 12:25:02
<u>S9987</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD (interface device and probe ) and glass	2003-08-11 12:24:11
<u>S9986</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD (interface device and probe ) and glass wafer	2003-08-11 12:23:59
<u>S9985</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD (interface device and probe ) and probe needle	2003-08-11 12:06:45
<u>S9984</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD (interface device and probe ) and ((324/\$)!.CCLS.)	2003-08-11 11:36:56
<u>S9983</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD (interface device and probe ) and guide member	2003-08-11 11:31:56
<u>S9982</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD (interface device and probe ) and elongate	2003-08-11 11:18:32
<u>S9981</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD interface device and probe	2003-08-11 11:17:57
<u>S9980</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD 5461326[uref]	2003-08-07 10:21:27
<u>S9979</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD (circuit board and distortion ) and compression link	2003-08-07 10:17:57
<u>S9978</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD (((circuit board and distortion )and compression )and force )and (IC or integrated circuit) ) and ((324/\$)!.CCLS.)	2003-08-07 10:13:27
<u>S9977</u>	<u>U</u>	USPT,PGPB,JPAB,EPAB,DWPI,TDBD (((circuit board and	2003-08-07